



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Izumi FUSEGAWA et al.

Group Art Unit: 1722

Application No.: 10/510,695

Docket No.: 121356

Filed: October 8, 2004

METHOD OF MANUFACTURING SILICON SINGLE CRYSTAL, SILICON

SINGLE CRYSTAL AND SILICON WAFER

SECOND REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which an error has been corrected in red. This error is being brought to the attention of the Patent and Trademark Office so that it may correct its records.

Respectfully submitted,

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WPB:JBK/rav

Date: July 25, 2006

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| | APPL NO. | FILING OR 371 (c) DATE | ART UNIT | FIL FEE REC'D | ATTY.DOCKET NO | DRAWINGS | TOT CLMS | IND CLMS | |
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| _ | 10/510,695 | 10/08/2004 | 1765 | 950 | 121356 | 3 | 9 | | |

25944 **OLIFF & BERRIDGE, PLC** P.O. BOX 19928 ALEXANDRIA, VA 22320



CONFIRMATION NO. 3939

FILING RECEIPT



Date Mailed: 04/05/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

SHIN-ETSU HANDOTAI CO., LTD, Tokyo, JAPAN

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/05167 04/23/2003

Foreign Applications

JAPAN 2002-122250 04/24/2002

Projected Publication Date: 07/07/2005

Non-Publication Request: No

Early Publication Request: No

Title

Method for producing silicon single crystal and, silicon single crystal and silicon wafer METHOD OF MANUFACTURING SILICON SINGLE Preliminary Class CRYSTAL, SILICON SINGLE CRYSTAL AND

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